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PATENT
Customer No. 22,852
Attorney Docket No. 8071.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takeshi MITSUISHI et al.

Application No.: 09/986,907

Filed: November 13, 2001

For: COMPOSITION FOR VAPOR
DEPOSITION, METHOD FOR
FORMING AN ANTIREFLECTION
FILM, AND OPTICAL ELEMENT

)
)
) Group Art Unit: 2872

)
) Examiner: Joshua Pritchett

TECHNOLOGY CENTER 2800

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one month extension of time to reply to the Office
Action of August 26, 2003. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge
any additional required fees to our deposit account 06-0916.

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Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: December 24, 2003

By: Charles E. Van Horn
Charles E. Van Horn
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